



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

MMB Docket No. **1003-0547**

LSI Reference: **99-230**

Application of: **Michael J. Berman**

Serial No.: **09/553,140**

Filed: **April 20, 2000**

Confirmation No.: **4444**

Group Art Unit: **2624**

Examiner: **Aaron W. Carter**

For: **Determination of Film Thickness During Chemical Mechanical Polishing**

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April 10, 2008

Date of Signature

**AMENDMENT**

Mail Stop Petitions  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Board of Patent Appeals and Interferences decision dated October 31, 2007, please amend the above-identified application as follows:

**Amendments to the Claims** begin on page 2 of this paper; and

**Remarks/Arguments** begin on page 9 of this paper.